Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/601,071	KIM, KYEONG JIN
Examiner	Art Unit

Eva Yi Zheng

2611

	SEARCHED					
Class	Subclass	Date	Examiner			
375	267	8/29/2007	E.Z			
375	260	8/29/2007	E.Z			
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INTERFERENCE SEARCHED				
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